

Name	Albert (Bert) Ellingboe
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## Education

1988	Bachelosrs of Science in Applied Math, Engineering, and Physics, University of
	Wisconsin, Madison
1998	PhD, The Australian National University, Helicon Plasma Source

## Professional experience

2000-present	Research Director, Plasma Research Lab, Dublin City University
2005-2010	President and CTO, Phive Plasma Technologies
1999-2000	Sr Engineering Staff, Lam Research, Lead Technologist in 300mm Dielectric
	Etcher
1997-1999	Engineering Staff, Applied Komatsu, Flat Panel Display Equipment Design
1995-1997	LLNL, Plasma Source and Surface Modification; PE-GILD
1989-1991	Varian Associates, Semiconductor Equipment Research & Tech-Transfer

1988-1989	IBM Yorktown Heights, Semiconductor Equipment Research & Tech-Transfer
	support

## Organizational experience

Period	Details